

Advanced combinational microfluidic multiplexer for fuel cell reactors

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Abstract. An advanced combinational microfluidic multiplexer capable to address multiple fluidic channels for fuel cell reactors is proposed. Using only 4 control lines and two different levels of control pressures, the proposed multiplexer addresses up to 19 fluidic channels, at least two times larger than the previous microfluidic multiplexers. The present multiplexer providing high control efficiency and simple structure for channel addressing would be used in the application areas of the integrated microfluidic systems such as fuel cell reactors and dynamic pressure generators.

1. Introduction

The micro fuel cell system requires simple and effective fluidic control system for the optimal amount of fuel delivery into multiple reaction chambers. Without effective fluidic control, the micro fuel cell requires numerous fluidic components in proportional to the number of the chambers, thus increasing costs for fuel cell systems. The effective microfluidic control system is essential to develop cheaper and more reliable micro fuel cell system.

Several microfluidic multiplexers for channel addressing have been proposed. The binary multiplexers analogic to electronic multiplexers are based on digital operation of pneumatic valves. They addressed up to $2^{n/2}$ channels using n control lines [1]. Previously, we had reported a high-radix microfluidic multiplexer based on the ternary or quaternary operation of pneumatic valves [2]. The valves in the high-radix multiplexers have different threshold pressures according to the membrane areas, thus providing high-radix operation. The ternary and quaternary multiplexers were capable to address $3^{n/2}$ and $4^{n/2}$ channels, using n control lines, respectively.

In this work, the proposed advanced combinational multiplexer based on the pressure combination in the control lines. By using 4 control lines, the present advanced combinational multiplexer can address up to 19 fluidic channels, at least three times larger than the previous binary and combinational multiplexers capable of only 4 and 6 channels, respectively. Even the ternary multiplexer was able to address 9 channels, a half of the proposed multiplexer using the same control lines. The present advanced combinational multiplexer having the high efficiency and simple structure can be widely used in the application areas of the integrated microfluidic systems such as fuel cell reactors and dynamic pressure generators.



2. Working Principle and Design

The present multiplexer is composed of control, membrane and channel layer (Fig. 1). The pneumatic pressure supplied from an external pressure source is delivered to membrane and the membrane deforms to the bottom channels by acting like pneumatic valves. The threshold pressure for valves is the minimum control pressure required to block the channel completely. Since a small membrane is hard to deform, it requires higher threshold pressure than larger membrane as shown in Fig. 1.

As an example for working principle of the advanced combinational multiplexer, two different pressures (50 and 100 kPa) and four control lines (C_1, C_2, C_3, C_4) are used as shown in Fig.2. Single inlet is branched to 19 channels and, in each control line, pneumatic valves having 50 and 100 kPa of threshold pressures ($V_{50 \text{ kPa}}$ and $V_{100 \text{ kPa}}$) are located. Among the total eight options (two different levels of pressures and four control lines), the selection of 4 maximizes the number of the pressure combinations and consequently the number of addressable fluidic channels [3].

Unfortunately, all selections of control pressures are not independent. When the control pressure of 100 kPa is selected in a control line, both $V_{100 \text{ kPa}}$ and $V_{50 \text{ kPa}}$ should be selected in the control line, because 100 kPa is higher pressure and covers the lower range of pressure. Therefore, selection of 100 kPa in a control line includes the selection of both $V_{50 \text{ kPa}}$ and $V_{100 \text{ kPa}}$ in the control line. All the channels having $V_{50 \text{ kPa}}$ or $V_{100 \text{ kPa}}$ in the control line are blocked. When we select two control lines for 100 kPa, all 4 options were chosen, since both $V_{50 \text{ kPa}}$ and $V_{100 \text{ kPa}}$ in two lines are selected. By

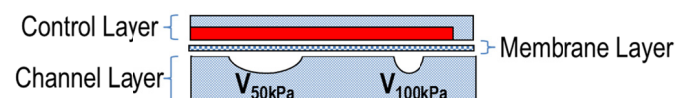


Figure 1. Cross-sectional view of pneumatic valves in the multiplexer, where $V_{100 \text{ kPa}}$ valve having smaller membrane area than $V_{50 \text{ kPa}}$ has higher threshold pressure for valve operation.

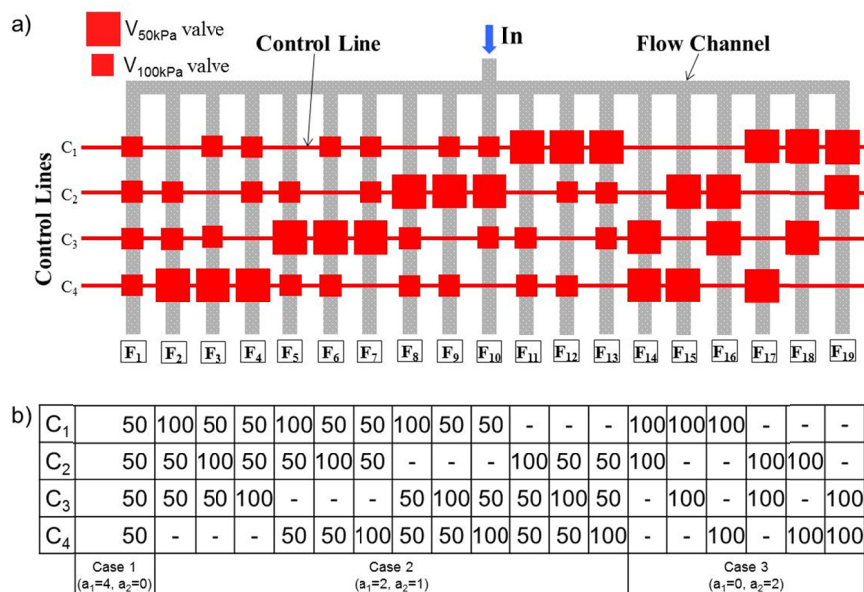


Figure 2. Schematic view of the present multiplexer capable to address 19 fluidic channels using 4 control lines: (a) Top view of the multiplexer; (b) Pressure combinations (kPa) in 4 control lines according to fluidic channels.

considering this dependency, the combination of four option selection needs to be divided into the following three cases,

Case 1) Four control lines are 50 kPa

All four control lines are selected as 50 kPa. The number of control pressure combination is ${}_4C_4 = 1$.

Case 2) One control line is 100 kPa, two control lines are 50 kPa

Due to the dependency of control pressure as we explained above, 100 kPa in a control line requires the selection of 50 kPa in the same control line. Once we choose one among four control lines for 100 kPa, 50 kPa is automatically selected and we lose one option. So cases are to choose two control lines among the four control lines for 50 kPa (${}_4C_2$) and choose one control lines among the remaining two (${}_2C_1$). Therefore, overall number of pressure combinations is ${}_4C_2 \times {}_2C_1 = 12$.

Case 3) Two control lines are 100 kPa

In this case, we need two control lines with 100 kPa. Each 100 kPa require 50 kPa in the same control line and no other options are left. The pressure combination is to choose two among four control lines, ${}_4C_2 = 6$.

Totally, the present advanced combinational multiplexer using 4 control lines can address 19 fluidic channels:

$$F = {}_4C_4 + ({}_4C_2 \times {}_2C_1) + {}_4C_2 = 19$$

3. Experimental Results

The device was fabricated by multi-layer soft lithography using Polydimethylsiloxane (PDMS). The SU-8 (Microchem. Co.) negative photoresist was patterned on a silicon wafer by UV-lithography process using manufacturer's recommendation and used as a mold master for soft lithography [2]. Figure 3 shows the fabricated device with an enlarged view of advanced combination multiplexer. In order to facilitate the visualization of channel flow, DI water was dyed by ink and injected to the channel layer in the multiplexer. There were no leaks of sample at the valves over time during the entire experiments.

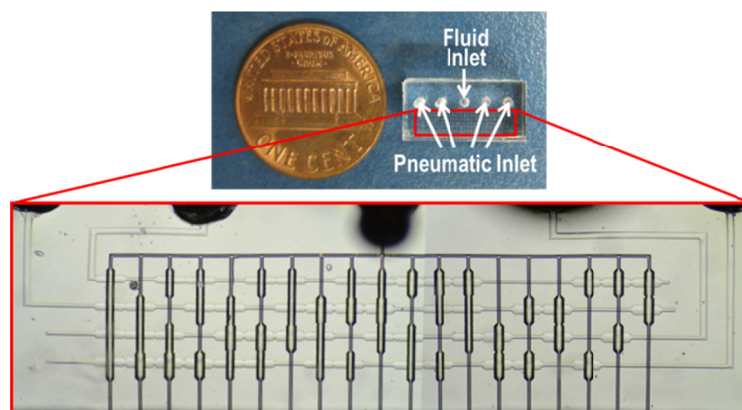


Figure 3. The fabricated multiplexer having one fluid inlet and four pneumatic inlets for flow control, with an enlarged view of the control lines and valve combination.

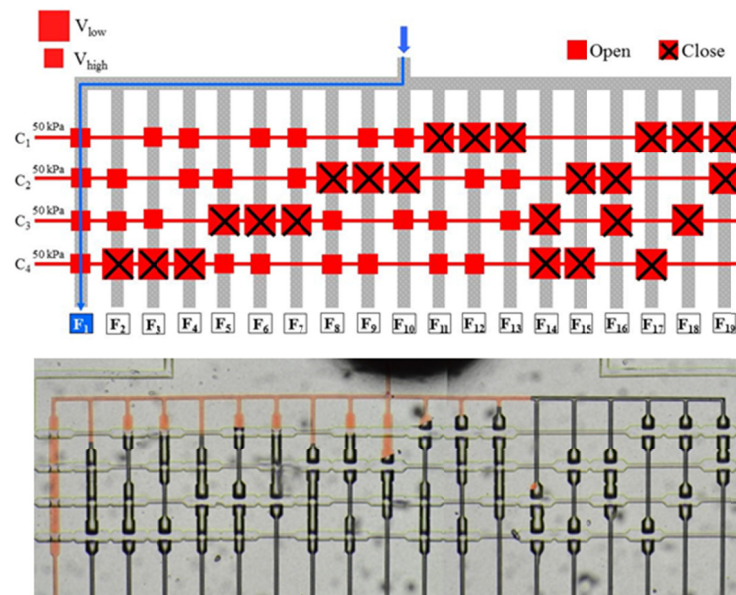


Figure 4. Fluidic channel addressing using the advanced combinational multiplexer: (a) F1 channel addressing where all control lines were pressurized to 50 kPa; (b) F18 channel addressing where only two control lines were pressurized to 100 kPa.

When we apply control pressure of 50 kPa in all control lines, all $V_{50\text{ kPa}}$ were closed, as shown in Fig.4. For example, F₂~F₄, F₁₄, F₁₅, F₁₇ channels were blocked by $V_{50\text{ kPa}}$ valves in the control line C₄. C₃ blocked F₅~F₇, F₁₆, F₁₈. The remaining F₈~F₁₃, F₁₉ were also blocked by C₁ or C₂. Since F₁ was the only channel having $V_{100\text{ kPa}}$ in all control lines, it was the only channel which was not blocked by the control pressure of 50 kPa in all control lines. Therefore, the solution was supplied from the inlet flowed through F₁.

4. Conclusion

As a proof-of-concept, we had verified the advanced combinational multiplexer could address up to 19 fluidic channels using four control lines, which is the largest number of channels so far. The present advanced combinational multiplexer having the high efficiency and simple structure will be used in the application areas of the integrated microfluidic systems.

Acknowledgements

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